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Substitute for form 1449B/PTO <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> Date Submitted: July 10, 2006 <i>(use as many sheets as necessary)</i>				<b>Complete if Known</b>	
Application Number		Unassigned			
Filing Date		12/28/2004			
First Named Inventor		Kazuya UEJIMA			
Group Art Unit		Unassigned 4136			
Examiner Name		Unassigned Duy T Nguyen			
Attorney Docket Number		065686-0163			
Sheet	1	of	1		

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
/D.N./	A1	2004/0135210	A1	NOGUCHI et al.	07-15-2004	
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Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Documents	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)				
/D.N./	A5	JP	2002-237590	A	UNIV TOHOKU	08-23-2002		A
/D.N./	A6	JP	2001-217433		SAMSUNG ELECTRONICS CO. LTD.	08-10-2001		A
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/D.N./	A11	EP	1 174 928	A1	HITACHI LTD.	01-23-2002		

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>6</sup>
/D.N./	A12	J.L. HOYT et al., "Strained Silicon MOSFET Technology," IEDM 2002, pp. 23-26.	
/D.N./	A13	M. TAMURA et al., "Secondary Defects in 1-10 keV As- and BF2-implanted Si," International Conference on Ion Implantation Technology Proceedings, pp. 744-747.	
/D.N./	A14	H.C. -H. WANG et al., "Substrate-Strained Silicon Technology: Process Integration," IEDM 2003, pp. 61-64.	

Examiner Signature	/Duy Nguyen/	Date Considered	10/29/2008
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